



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/653,149
Filing Date August 31, 2000
Inventor Garo J. Derderian, et al.
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner T. Lee
Attorney's Docket No. MI22-1330
Title: Capacitor Fabrication Methods Including Forming a Conductive Layer

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
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Spokane, WA 99201-3828

References - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

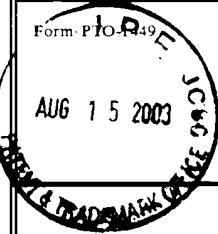
Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 15 Aug 2003

By: _____

James E. Lake
Reg. No. 44,854

Form PTO-449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1330		SERIAL NO. 09 653,149	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Garo J. Derderian			
FILING DATE August 31, 2000				GROUP 2818			
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	6,222,722	04/99	Fukuzumi et al				
AB	6,204,070	3/01	Kim				
AC	6,207,487	3/01	Kim et al				
AD	6,391,803	5/02	Kim et al				
AE							
AF							
AG							
AH							
AI							
AJ							
AK							
FOREIGN PATENT DOCUMENTS							
Document Number	Date	Country	Class	Subclass	Translation		
					Yes	No	
AL	KR 2002002157A	1/02	Korea				
AM							
AN							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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MI22-1330SERIAL NO.
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APPLICANT Garo J. Derderian

FILING DATE
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U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA	09:590,795		Agarwal et al (as filed and amended 10/29/01 & 1/6/03)			06:00
AB	09:653,156		Agarwal (as amended 2/18/2003)			
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						
AK						

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AL							
AM							
AN							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AO		
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